



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/724,300
Applicant(s) : HAAS, Thomas et al.
Filed : 11/26/2003
TC/A.U. : 1625
Examiner : OWENS, Amelia A.
Title : Process for the Epoxidation of Olefins

Confirmation No.: 8776

Docket No. : 032301.320
Customer No. : 25461

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Commissioner for Patents
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Sir:

INFORMATION DISCLOSURE STATEMENT
FILED CONCURRENTLY WITH
REQUEST FOR CONTINUED EXAMINATION

This paper respectfully requests consideration of the Information Disclosure Statement (IDS) that is submitted herewith. Pursuant to MPEP § 609, the IDS is filed concurrently with a Request for Continued Examination (RCE), and therefore prior to a first Office Action. Accordingly, no additional fees are believed to be due.

In view of the foregoing, it is respectfully requested that the cited document be considered by the Examiner in the above-identified patent application and that the cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,

By: Robert G. Weilacher, Reg. No. 20,531

Dated: August 9, 2005
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet	1	of	1
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Attorney Docket Number	032301.320
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Complete if Known

Application Number	10/724.300
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<i>Filing Date</i>	11/26/2003
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First Named Inventor	HAAS, Thomas et al.
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Art Unit	1625
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Examiner Name	OWENS, Amelia A.
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Attorney Docket Number	032301.320
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U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

Examiner Signature		Date Considered	
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